WHAT IS CLAIMED IS:

l	1.	A microstructure for steering light, the microstructure comprising:		
2	a substrate;			
3	a fir	a first tiltable assembly connected with the substrate, the first tiltable assembly		
4	including a reflective	ve coating;		
5	a sec	cond tiltable assembly connected with the substrate; and		
6	first	and second electrodes connected with the substrate and respectively		
7	configured to tilt th	to tilt the first and second tiltable assemblies upon activation such that the first		
8				
	·	- Long Londonnia the first tiltable		
1.	2.	The microstructure recited in claim 1 wherein the first tiltable		
2	assembly is config	ured as a cantilever arrangement.		
·. 1	3.	The microstructure recited in claim 2 wherein the second tiltable		
2	•	ured as a torsion-beam arrangement.		
_				
1	4.	The microstructure recited in claim 1 wherein the second tiltable		
2	assembly is config	ured as a torsion-beam arrangement.		
1	5.	The microstructure recited in claim 1 wherein the reflective coating		
2	comprises gold.			
1	6.	The microstructure recited in claim 1,		
2	wherein the first tiltable assembly includes:			
3	· ·	a first structural linkage connected with the substrate;		
4		a first structural film supported by the first structural linkage and		
5	having a plurality of fingers at an end of the first structural film, with the reflective coating o			
6				
7		erein the second tiltable assembly includes:		
8	•	a second structural linkage connected with the substrate; and		
J				
9		a second structural film supported by the second structural linkage and		
10	having a plurality	of fingers at an end of the second structural film.		
1	7.	The microstructure recited in claim 6 wherein the first and second		
1				
2	electrodes compr	iso porysimoon.		

1	8. The microstructure recited in claim 6 wherein the first and second	
	structural films comprise polysilicon.	
_	wherein the first structural	
1	The microstructure recited in claim o wherein the second structural linkage.	
2	linkage has a greater height above the substrate than the second structural linkage.	
1	10. A method for fabricating a microstructure for steering light, the	
2 .	method comprising:	
3	forming a first tiltable assembly on a substrate, the first tiltable assembly	
4	including a reflective coating;	
5	forming a second tiltable assembly on the substrate; and	
. 6	forming first and second electrodes on the substrate, such first and second	
	electrodes being configured to tilt the first and second tiltable assemblies upon activation	
7	such that the first and second tiltable assemblies interdigitate.	
. 8		
-1	11. The method recited in claim 10 wherein forming the first tiltable	
2	assembly comprises creating a cantilever arrangement.	
1	12. The method recited in claim 11 wherein forming the second tiltable	
2	assembly comprises creating a torsion-beam arrangement.	
1	The method recited in claim 10 wherein forming the second tiltable	
2	assembly comprises creating a torsion-beam arrangement.	
1	14. The method recited in claim 10 wherein the reflective coating	
2	comprises gold.	
1	15. The method recited in claim 10,	
2	wherein forming the first tiltable assembly includes:	
	forming a first structural linkage on the substrate,	
	forming a first structural film on the first structural mikego, and	
	structural film having a plurality of fingers at an end of the first structural film, with the	
conflective coating deposited on the first structural film; and		
	wherein forming the second tiltable assembly metudes.	
	forming a second structural linkage on the substrate; and	

0	for	ming a second structural film on the second structural linkage, the
9	atmosparal film has	ring a plurality of fingers at an end of the second structural film.
10		
1	. 16. Th	e method recited in claim 15 wherein forming the first structural
2	linkage comprises formin	g the first structural linkage on the substrate at a height greater than
3	the second structural link	age.
		method for operating an optical switch, the method comprising:
1	17. A	method for operating an optical switch, the first assembly
2	tilting a fi	rst assembly by applying a first electrostatic force, the first assembly
3	including:	
4	. a	first structural linkage connected with a substrate;
5		first structural film supported by the first structural linkage and
6	having a plurality of fing	gers at an end of the first structural film; and
7	a	reflective coating on the first structural film;
8	tilting a s	second assembly by applying a second electrostatic force, the second
9	assembly including:	
10	· a	second structural linkage connected with the substrate; and
11		second structural film supported by the second structural linkage and
12	having a plurality of fin	gers at an end of the second structural film; and
13	holding	the first and second assemblies electrostatically in a fixed position
. 14	with the fingers of the f	first and second structural films interdigitated.
1		The method recited in claim 17 wherein the first assembly is
2	configured as a cantile	ver arrangement.
. 1	19.	The method recited in claim 18 wherein the second assembly is
1 2		
. 2		
1	20.	The method recited in claim 17 wherein the second assembly is
2	configured as a torsion	n-beam arrangement.
	21	The method recited in claim 17 wherein the reflective coating
	1 21.	The mediod recited in the second seco
2	2 comprises gold.	
. ,	1 22.	The method recited in claim 17 wherein tilting the first assembly
	2 comprises tilting the	end of the first structural film having a plurality of fingers towards the

•	substrate and tilting the second assembly comprises tilting the end of the second structural		
3	n having a plurality of fingers away from the structural assembly.		
4			
1	A microstructure for steering light, the microstructure comprising:		
2	support means;		
3	tiltable micromirror means connected with the support means;		
4	tiltable spare means connected with the support means; and		
5	means for generating electrostatic forces for tilting the tiltable micromiffor		
6	means and the tiltable snare means into an interdigitated configuration.		
1	The microstructure recited in claim 23 wherein the tiltable micromirror		
. 2	means comprises cantilever means.		
1	The microstructure recited in claim 28 wherein the snare means		
2	comprises torsion-beam means		
1	26. The microstructure recited in claim 23 wherein the micromirror means		
2	comprises torsion-beam means.		
. –	the reuter for receiving, at an input port, light having a		
1	27. A wavelength router for receiving, as a plurality of spectral bands and directing subsets of the spectral bands to respective ones of a		
2	plurality of spectral bands and directing subsets of the spectral		
3	plurality of output ports, the wavelength router comprising: a free-space optical train disposed between the input port and the output ports		
4	a free-space optical train disposed between the day		
5	providing optical paths for routing the spectral bands, the optical train including a dispersive		
ϵ	element disposed to intercept light traveling from the input port; and a routing mechanism having at least one dynamically configurable routing		
٠.	a routing mechanism having at least one dynamics.		
;	a routing mechanism not may be a routing mechanism not may be a routing mechanism not may be a routing on a state of the element to direct a given spectral band to different output ports depending on a state of the element to direct a given spectral band to different output ports depending on a state of the		
,	element to direct a given spectral band to direct a given spec		
1	o element includes: a tiltable micromirror assembly having a micromirror structural film		
1	a tiltable micromirror assentoty naving a tiltable micromirror structural film:		
1	with a plurality of fingers at an end of the micromirror structural film; a tiltable snare assembly having a snare structural film with a plurality		
1			
7	of fingers at an end of the snare structural film; and		
	to allow of electrodes configured to the incromment		
	a plurality of electrodes stands a plurality of electrodes stands and snare assembly upon activation such that the fingers of the micromirror structural film		
	and snare structural film interdigitate.		

- 1 28. The wavelength router recited in claim 27 wherein the micromirror 2 assembly is configured as a cantilever arrangement.
- 1 29. The wavelength router recited in claim 28 wherein the snare assembly 2 is configured as a torsion-beam arrangement.